Docket No.: 02008/071003
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Masahiro Ishida et al.

Application No.: 10/779,904 Confirmation No.: 9608

Filed: February 17, 2004 Art Unit: 2436

For: METHOD AND APPARATUS FOR DEFECT ANALYSIS OF SEMICONDUCTOR INTEGRATED CIRCUIT Examiner: O. A. Louie

REPLY UNDER 37 CFR § 1.111

MS: Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated June 24, 2009, please reconsider this application in view of the following.